10/580513

IAP9 Rec'dPCTIPTO 24 MAY 2006

U.S. DEPARTMENT OF COMMERCE					
PATENT AND TRADEMARK OFFICE					
INFORMATION DISCLOSU STATEMENT	VRE .	Docket Number: 12418/7			
Application Number	Filing Date	Examiner	Art Unit		
To Be Assigned	Herewith	To Be Assigned	To Be Assigned		
METHOD FOR THE NON-DEST TESTING OF AN ELEMENT FO REACTOR		Applicant(s) Philippe MAHE			

Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:

te: 5 2

John M. Vereb (Reg. No. 48.912)

- 1. In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorneys for Applicants hereby bring the following references to the attention of the Examiner. The references are listed on the attached modified PTO Form No. 1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that these references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.
- 2. The filing of this Information Disclosure Statement and the enclosed PTO Form No. 1449, shall not be construed as an admission that the information cited is prior art, or is considered to be material to patentability as defined in 37 C.F.R. §1.56(b).
- 3. In accordance with the Official Gazette of August 5, 2003, which stated that the United States Patent and Trademark Office waived the requirement under 37 C.F.R. § 1.98 (a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. patent application publication for all U.S. patent applications filed after June 30, 2003, copies of each of the cited U.S. patents and U.S. patent application publications are not being provided.

Dated: 5 10 b By: John M. Vereb (Reg. No. 48,912)

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CUSTOMER NO. 26646

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INFORMATION DISCLOSURE
STATEMENT BY APPLICANTS
PTO FORM 1449

ATTY. DOCKET NO. 12418/7	SERIAL NO. TBA
APPLICANT(s) Philippe MAHE	
FILING DATE Herewith	GROUP TBA

U.S. PATENT DOCUMENTS

				1		
EXAMINER INITIAL	PATENT NUMBER	PATENT DATE	NAME	· CLASS	SUBCLASS	FILING DATE
/SCC/	6,154,561	11/28/00	Pratt et al.			
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FOREIGN PATENT DOCUMENTS

						TRANS	LATION
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	МО
/SCC/							
0000000	EP 0 597 639	5/18/94	EP				
	DE 3809221	9/28/89	Germany				
V	WO 97/16921	5/9/97	PCT			<u> </u>	

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC. Patent Abstracts of Japan, JP 2000249785, 9/14/2000; volume 2000, no. 12,
/SCC/	Mitsubushi Nuclear Fuel Co. Ltd., "Inspecting Wethod and System or y terms
/SCC/	"Image Analysis and Mathematical Morphology", Ac. Press, Vol. 1 (1982), Vol. 2 (1988).
/SCC/	Jourlin and Pinoli, "A Model for logarithmic image processing", J. of Microscopy, Vol. 149, Pt. 1, January 1988, pp. 21-35.

			04/13/2009 Date considered
	- 40 100	/Sheela Chawan/	DATE CONSIDERED
EXA	MINER	TOTIOGIA OTIGNATI	he situation if not in conformance and not

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.